



Serial No. 09/977,238
SEC.895

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Chung-Sam JUN et al.

Group Art Unit: 2812

Serial No.: 09/977,238

Examiner: Unknown

Filed: October 16, 2001

FOR: METHOD AND APPARATUS FOR NUMERICALLY ANALYZING GRAIN
GROWTH ON SEMICONDUCTOR WAFER USING SEM IMAGE

STATUS CHECK

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Status Check**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Kindly immediately advise the undersigned of the status of the above-identified application.

Respectfully submitted,

Volentine Francos, P.L.L.C.

A handwritten signature in black ink, appearing to read "A. Volentine".

Adam C. Volentine
Registration No. 33,289

12200 Sunrise Valley Drive, Suite 150
Reston, Virginia 20191
Telephone No.: (703) 715-0870
Facsimile No.: (703) 715-0877

Date: November 4, 2003